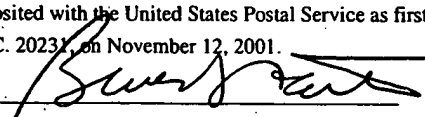


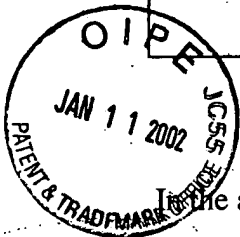
1782

PATENT
19937-20035.00

CERTIFICATE OF MAILING BY "FIRST CLASS MAIL"

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Assistant Commissioner for Patents, Washington, D.C. 20231, on November 12, 2001.


Beverly S. Carter



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Takayuki TOSHIMA et al

Serial No.: 09/971,136

Filing Date: October 3, 2001

For: SUBSTRATE PROCESSING METHOD
AND SUBSTRATE PROCESSING
APPARATUS

Examiner: Unknown

Group Art Unit: Unknown

RECEIVED
JAN 18 2002
IC 1700

TRANSMITTAL OF PRIORITY DOCUMENTS

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

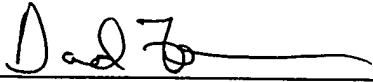
Dear Sir:

Enclosed herewith are certified copies of Japanese Patent Application No. 2000-304375 filed October 4, 2000 and Japanese Patent Application No. 2001-041482 filed February 19, 2001, from which priority is claimed under 35 U.S.C. 119 and Rule 55.

Acknowledgement of the priority documents is respectfully requested to ensure that the subject information appears on the printed patent.

Dated: November 12, 2001

Respectfully submitted,

By: 
David L. Fehrman
Registration No. 28,600

Morrison & Foerster LLP
555 West Fifth Street
Suite 3500
Los Angeles, California 90013-1024
Telephone: (213) 892-5601
Facsimile: (213) 892-5454

